Attorney Docket 0553-0246

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	
Koichiro Tanaka) I hereby certify that this correspondence is being deposited with the United States
Serial No. 09/812,529) Postal Service as first class mail in an envelope addressed to:
Filed: March 20, 2001	Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 11240
For: Method of Manufacturing a Semiconductor Device	Shorron Wallace
Art Unit: 2812) Mayloredon 211 2000
Examiner: Richard A. Booth	Pate: November 24,2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT H (AFTER ALLOWANCE)

Sir:

In furtherance of the Notice of Allowance, please amend the above-identified application as follows: